

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Xiaolei Shi et al.

Appl. No.: 10/814,697

Filed: 30 March 2004

Title: NEAR FIELD OPTICAL STORAGE MASK LAYER, DISK, AND  
FABRICATION METHOD

Conf. No.: 7228

Art Unit: 1795

Examiner: Anna L.Verderame

Docket No.: 140264-1

Customer No.:06147

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REPLY**

(In compliance with 37 CFR § 1.111)

In response to the Office communication dated March 24, 2008, please amend the above-identified application as follows:

**Listing of Claims** begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.